Johan Böhlmark

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/10952863/publications.pdf

Version: 2024-02-01

3 1,164 3 3 3 g-index

3 3 3 918

times ranked

citing authors

docs citations

all docs

#	Article	IF	CITATIONS
1	Ionized physical vapor deposition (IPVD): A review of technology and applications. Thin Solid Films, 2006, 513, 1-24.	1.8	886
2	lonization of sputtered metals in high power pulsed magnetron sputtering. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2005, 23, 18-22.	2.1	214
3	Measurement of the magnetic field change in a pulsed high current magnetron discharge. Plasma Sources Science and Technology, 2004, 13, 654-661.	3.1	64